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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

REQUEST FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)		Docket Number: 10191/1614	Conf. No.: 3872
Application Number 09/720,720	Filing Date February 28, 2001	Examiner Binh TRAN	Art Unit 1765
Invention Title METHOD FOR ELIMINATING DEFECTS IN SILICON ELEMENTS THROUGH SELECTIVE ETCHING		Inventor: Richard SPITZ et al.	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

Dated: June 26, 2003

Reg. No. 36,197

Signature: 

Jong H. Lee

Applicants respectfully request a one-month extension of time in which to respond to the office action dated March 17, 2003, for which a response period expiring on June 17, 2003, was set. The extended period expires on July 17, 2003.

1. The Commissioner is hereby authorized to charge payment of the 37 C.F.R. § 1.136(a) extension fee of **\$110.00** to the Deposit Account of **Kenyon & Kenyon**, Deposit Account number **11-0600**. The office is also authorized to charge any additional fees, or credit overpayments, associated with this paper to Deposit Account **11-0600**.
2. A duplicate copy of this form is enclosed.

Dated: June 26, 2003

By: 

Jong H. Lee (Reg. No. 36,197)

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